


<b>Search Notes</b>  	<b>Application/Control No.</b>  10699991	<b>Applicant(s)/Patent Under Reexamination</b>  LERNER ET AL.
	<b>Examiner</b>  Kim, Jennifer	<b>Art Unit</b>  1617

SEARCHED			
Class	Subclass	Date	Examiner
514	361	6/25/2007	jmk
	Updated	4/1/2008	jmk
	Updated	1/5/2009	jmk

SEARCH NOTES		
Search Notes	Date	Examiner
STIC	6/25/2007	jmk
Updated	4/1/2008	jmk
Updated	1/5/2009	jmk

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

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